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APPLICANTS

Yoshijiro Ushio, Yokohama-shi, JAPAN;
 Kiyoshi Iizuka, Tokyo, JAPAN;

** CONTINUING DATA ***** *yes S.A.*
 This application is a CON of PCT/JP02/08349 08/19/2002

** FOREIGN APPLICATIONS ***** *yes S.A.*
 JAPAN 2001-251421 08/22/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>S.A.</i> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 43	INDEPENDENT CLAIMS 7
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ADDRESS
 09629
 MORGAN LEWIS & BOCKIUS LLP
 1111 PENNSYLVANIA AVENUE NW
 WASHINGTON, DC
 20004

TITLE
 Method and device for simulation, method and device for polishing, method and device for preparing control parameters or control program, polishing system, recording medium, and method of manufacturing semiconductor device

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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